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## BIB DATA SHEET

CONFIRMATION NO. 2457

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/530,848	05/06/2006	438	2891	85267
<b>RULE</b>				
<b>APPLICANTS</b> Armin Gerhard Aberle, Botany, NSW, AUSTRALIA; Per Ingemar Widenborg, Kogarah, NSW, AUSTRALIA; Axel Straub, Kingsford, NSW, AUSTRALIA; Dirk-Holger Neuhaus, Freiberg/Saxony, GERMANY; Oliver Hartley, Leipzig, GERMANY; Nils-Peter Harder, Hameln, GERMANY;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/AU03/01313 10/07/2003				
<b>** FOREIGN APPLICATIONS *****</b> AUSTRALIA 2002951838 10/08/2002				
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 08/02/2006				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/JULIA SLUTSKER/</u> Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> NSW	<b>SHEETS DRAWINGS</b> 6	<b>TOTAL CLAIMS</b> 20
<b>INDEPENDENT CLAIMS</b> 1				
<b>ADDRESS</b> FITCH EVEN TABIN AND FLANNERY 120 SOUTH LA SALLE STREET SUITE 1600 CHICAGO, IL 60603-3406 UNITED STATES				
<b>TITLE</b> Fabrication method for crystalline semiconductor films on foreign substrates				
<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	